APPENDIX D BAAQMD PERMIT APPLICATION FORMS



BAY ÅREA AIR QUALITY MANAGEMENT DISTRICT

939 Ellis Street . . . San Francisco, CA 94109 (415) 749-4990 . . . FAX (415) 749-5030

FORM P-101B

AUTHORITY TO CONSTRUCT PERMIT TO OPERATE

Application Information

Application No.		Plant No.	26			
(assigned by District)			(leav	e blank if unknown)		
Business Name Mirant Potrero, LLC						
Equipment Description see attached application						
If you qualify for the District's Accelerated Permitting Program , of If you are applying to permit or to register portable equipment , in	•			neck here		
New Plant Information If you have not previously been assigned a Plant Number by the District or if you want to update any Plant data that you have previously supplied to the District, please complete the New Plant Information box below.						
Plant Address (equipment location)						
City		State		Zip		
Mailing Address						
City		State		Zip		
Plant Contact						
Title						
Telephone	Fax					
E-mail Address						
Application Contact Information (if different from plant contact) All correspondence regarding this application will be sent to the above plant contact person unless you wish to designate a different contact for this application.						
Application Contact Ronald Kino						
Title/Company Manager, Environmental Health and Safety						
Mailing Address 1350 Treat Blvd., Suite 500						
City Walnut Creek		State	CA	Zip 94596		
Telephone (925) 287-3118	Fax (925) 947	7-3001				
E-mail Address ronald.kino@mirant.com						
Small Business Certification						
You are entitled to a reduced permit fee if you qualify as a small business as defined by BAAQMD Regulation 3. In order to qualify, you must certify that your business meets all of the following criteria: The principal office is in California, and its officers live in California. The business is independently owned and operated. The business is not dominant in its field of operation and is not an affiliate of a non-small business. If a non-manufacturer, it does not employ more than 25 persons and its annual receipts do not exceed \$1 million. If a manufacturer, it does not employ more than 50 persons and its annual receipts do not exceed \$5 million.						
Signature:	Da					

Accelerated Permitting Program

abatement equipment without wa	l iting for the District to iss your project will meet <u>all</u> of t	ue a Pern	ualifying sources of air pollution and nit to Operate. In order to participate in ng criteria. Please acknowledge each
Uncontrolled emissions of any si precertified by the BAAQMD.	ingle pollutant are each less that	an 10 lb/hig	hest day, or the equipment has been
Emissions of toxic compounds d	lo not exceed the trigger levels	identified in	Table 2-1-316 (see District Regulation 2,
For replacement of abatement e efficiency for all pollutants than to	quipment, the new equipment in the equipment being replaced.	must have a	an equal or greater overall abatement
The project is not subject to publisource does not emit any toxic c	lic notice requirements (source ompound in table 2-1-316).	is either m	ore than 1000 ft. from the nearest school, or
The minimum permit fee paymer the small business criteria by corsource. Additional permit fees m	mpleting that portion of this form	n, the minir	ne application. If you certify that you meet mum permit fee payment is \$269.00 per n is evaluated.
Signature:			Date:
,	All Applicati	ons	
All applications should contain the	following additional information	ion:	
	or each piece of equipment (da phly to scale, that locates the e otion, manufacturer's data		•
	elating to emissions from the ed	quipment	
	eet map showing the location of		ess
ereby certify that the sources in	• • • • • • • • • • • • • • • • • • • •		
	nin 1,000 feet of the outer boun	-	
for this project? \square no \boxtimes yes If ye	es, by whom?URS Corp	,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,	ality Act (CEQA) document been prepared -
public record and may be disclosed to	a third party. If you wish to kee	p certain ite	rmit application will be considered a matter of ems separate as specified in
Regulation 2, Rule 1, Section 202.7, plo (a) Make a copy of any page conta page "Public Copy."			fidential information blanked out. Label this
(b) Label the original page "Confid			page. em. Append this to the confidential copy.
Signature:	,		Date:
Mail the completed application to:	Bay Area Air Quality Mana 939 Ellis Street San Francisco, CA 94109 Attention: Permit Services D		strict
below. If you are uncertain which data please call the Permit Services Division (<i>Oakland</i>), 925-229-9972 (<i>Martinez</i>), or www.baaqmd.gov.	form to use, need additional da on at (415) 749-4990 or contact	ata forms, on the our Perm orms are als	it Assistance Centers at 510-286-6991 so available on the District's website at
Form A Abatement Device Form D Dry cleaner		Form C Form F	Combustion Equipment Semiconductor Fabrication
Form G Other Miscellaneou	us	Form SC	Solvent Cleaning Operation
Form S Surface Coating Form T Organic Liquid Loa	ding/Storage	Form SS Form P	Form S supplement for printers Emission Point

DATA FORM G General Air Pollution Source



BAY AREA AIR QUALITY MANAGEMENT DISTRICT

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Form G is for general air pollution sources. Use specific forms when applicable. If this source burns fuel, then also complete Form C.

1.	Business Name: Mirant Po	trero, LL0	C		Plant No:	26
2.	SIC No.: D					(if unknown, leave blank)
	Name or Description: Coolir					e No.: S- 59
	Make, Model, and Rated Capac			4 cell, 140,000		
	Process Code ¹ 7104		aterial Code ²			
6.	Total throughput, last 12 mos.		_			usage units ² /hr
	Typical % of total throughput:		•		*	Sep-Nov 25 %
	Typical operating times: 24	_			-	•
	For batch or cyclic processes:					
		Wet gas	flowrate 1.7 mm	_ cfm	at Amb.	_ °F
for c emis	is source also burns fuel, do not on Form C. If source test or othe ssions attributable to just the ge Check box if factors apply to em	er data ai neral pro	re available for composess and show below. after Abatement Device Emission Factors	e(s).	ssion factors below only, estimate fron Basis Code ³	w; they are accounted a those data the
			Ib/Usage Unit ²			
	Particulate		Table 4-1			***************************************
	Organics		<u> </u>			
	Nitrogen Oxides (as NO ₂)					
	Sulfur Dioxide				M1	
	Carbon Monoxide		***************************************			
	Other:				A	A
		*********	1			
δ.	With regard to air pollutant flow immediately downstream?	Trom this	s source, what sources	s(s), abatement	device(s) and/or	emission point(s) are
S	S- S-	S-	Α	Α-	Α-	
F	P. 59 P.	P.	A P-	P		Marie Commission Commi
	Tables G-1 through G-7 for code Basis Code Table below		_	the Material Co	odes Table (availat	ole upon request)
ers	son completing this form:	Mark Str	ehlow		Date: 07/	/17/03





P:www\FormA (revised: 7/99)

BAY AREA AIR QUALITY MANAGEMENT DISTRICT 939 Ellis Street . . . San Francisco, CA 94109 . . . (415) 749-4990 . . . FAX (415) 749-5030

siness Name:	Mirant Potrero, I	LLC			Plant No: 26 (If unknown, leave b
me or Description	on Granular Ad	ctivated Carbon Bed	– Odor Control Syste	Abatement Devi	ce No: <u>A- 60</u>
ke, Model, and	Rated Capacity	TBD			
atement Device	Code (See table*)	_56	Da	ate of Initial Operation	
h regard to air ¡ stream?	pollutant flow into th	nis abatement device	, what sources(s) and	d/or abatement device(s) are immediately
S- 60	S-	S-	S-	S	
}-	A-	A-	A-	A-	A-
form is being s mandatory.	n temperature at inle submitted as p If not, and the	art of an applicati Abatement Device	ce is already in o	rity to Construct, on peration, completion Basis Codes	completion of the fo
form is being s mandatory t required.	submitted as p	art of an applicati	ion for an <i>Author</i> ce is <i>already in op</i>	peration, completion	completion of the fo
form is being s mandatory t required.	submitted as p	art of an application Abatement Device Weight Percent	ion for an <i>Author</i> ce is <i>already in op</i>	peration, completion Basis Codes	completion of the fo
form is being s mandatory. t required. Pollo Particulate	submitted as p	art of an application Abatement Device Weight Percent	ion for an <i>Author</i> ce is <i>already in op</i>	peration, completion Basis Codes	completion of the fo
form is being s mandatory. t required. Pollicarticulate Drganics	submitted as p If not, and the	art of an application Abatement Device Weight Percent (at typical open	ion for an <i>Author</i> ce is <i>already in op</i>	peration, completion Basis Codes (See Table**)	completion of the fo
form is being s mandatory t required. Pollicarticulate Organics Nitrogen Oxides	submitted as p If not, and the	art of an application Abatement Device Weight Percent (at typical open	ion for an <i>Author</i> ce is <i>already in op</i>	peration, completion Basis Codes (See Table**)	completion of the fo
form is being s mandatory. t required. Pollication of the policy of the	utant (as NO ₂)	art of an application Abatement Device Weight Percent (at typical open	ion for an <i>Author</i> ce is <i>already in op</i>	peration, completion Basis Codes (See Table**)	completion of the fo
form is being s mandatory. t required. Pollicarticulate Organics Nitrogen Oxides Sulfur Dioxide Carbon Monoxid	utant (as NO ₂)	art of an application Abatement Device Weight Percent (at typical open	ion for an <i>Author</i> ce is <i>already in op</i>	peration, completion Basis Codes (See Table**)	completion of the fo
form is being s mandatory t required. Polling Particulate Organics Nitrogen Oxides Sulfur Dioxide Carbon Monoxid	utant (as NO ₂)	art of an application Abatement Device Weight Percent (at typical open	ion for an <i>Author</i> ce is <i>already in op</i>	peration, completion Basis Codes (See Table**)	completion of the fo
form is being s mandatory. t required. Pollication of the control	utant (as NO ₂) this Abatement Deve No.) and attach to pollutant flow from	Weight Percent (at typical open) vice burns fuel; componing this form.	Reduction eration)	peration, completion Basis Codes (See Table**)	n of the table is rec

DATA FORM P Emission Point

		JALITY MANAGEI A 94109 (415) 74	MENT DISTRICT 49-4990 Fax (415) 7	49-5030			
Form P is for we windows, room v		sion points such a	s stacks or chimne	ys only;	do not us	se for	
Business Name:	Mirant Potrero, LL	.c			Plant No:	26	
odor Control System Vent		Emission F	Point No:	P-60			
With regard to a immediately up	·	into this emission	point, what source	es(s) and	d/or abate	ement dev	ice(s) are
S- S-	S- 60	S- A-	S	_ S- _ A-		Α	
it cross-section	area: <u>1.95</u>	sq. ft.	Height above (grade: <u>20</u>	ft.		
		Effluent	Flow from Stack				
		Typical Oper	esting Condition	Maxin	num Oper	rating Con	dition
		i ypioai opei	rating Condition	1010074771			
Actual Wet C	as Flowrate	5,900	cfm	same	•		cfm
Actual Wet C							cfm Vol %
	er Vapor	5,900	cfm	same			
Percent Wate Temperature If this stack is ed Is monitoring	er Vapor quipped to mea continuous?	5,900 saturated Ambient sure (monitor) the	cfm Vol %	same same same	nts,		/ol %

DATA FORM P Emission Point

BAY AREA AIR QUA	LITY MANAG	EMENT DISTRICT		
939 Ellis Street San Francisco, CA	94109 (415	i) 749-4990 Fax (415) 7-	49-5030	
Form P is for well-defined emissi windows, room vents, etc.	on points suct	n as stacks or chimne	ys only; do not use	e for
Business Name: Mirant Potrero, LLC			Plant No:	26
Unit 7 Cooling Tower		Emission F	Point No: P-59	
With regard to air pollutant flow i immediately upstream?	nto this emiss	ion point, what source	es(s) and/or abater	ment device(s) are
S- 59 S-	S	S-	S-	•
S A	A-	A	_ A	A
Exit cross-section area: 12,450	sq. ft.	Height above	grade: 69	<u>ft.</u>
	Efflue	nt Flow from Stack		
	Typical O	perating Condition	Maximum Opera	ating Condition
Actual Wet Gas Flowrate	1,601,000	cfm	1,757,500	cfm
Percent Water Vapor	saturated	Vol %	saturated	Vol %
Temperature	Ambient	°F	Ambient	°F
If this stack is equipped to meas	ure (monitor)	the emission of any a	uir pollutants,	
Is monitoring continuous?	☐ yes	⊠ no		
	-			
What pollutants are monitore	-			
What pollutants are monitore	-			